

Course Schedule, group M17-304**MONDAY**

10:15 — 11:00	■	LEC	Elect	Planar Cycle Technology	🎓 Kozyrev A.A.	📍 FIAN
11:05 — 12:40	■	SEM	Elect	Planar Cycle Technology	🎓 Kozyrev A.A.	📍 FIAN
14:30 — 17:50	■	LEC		Methodology of Science (2019-02-04 — 2019-03-04)	🎓 Mironova N.B., Arshinov V.I.	📍 A-100

TUESDAY

08:30 — 10:05	■	LEC	Opt	Military Training (2019-02-05 — 2019-04-23)	📍 dep.20
10:15 — 16:05	■	SEM	Opt	Military Training (2019-02-05 — 2019-04-23)	📍 dep.20

WEDNESDAY

09:20 — 11:50	■	LEC		Modern optics (2019-02-06 — 2019-02-13)	🎓 Kulchin Y.N.	📍 FIAN
	■	SEM		Modern optics (2019-02-20 — 2019-04-10)	🎓 Kulchin Y.N.	📍 FIAN
12:45 — 14:20	■	SEM	Elect	Physics and Technology of Semiconductor Lasers	🎓 Mikaelyan G.T.	📍 FIAN
14:30 — 16:05	☑	LEC	Elect	Physics and Technology of Semiconductor Lasers	🎓 Mikaelyan G.T.	📍 FIAN
	☑	PR		Practical Training (Research Work)	🎓 Marmalyuk A.A., Krohin O.N., Kanavin A.P., Zasavitskiy I.I., Bezotosnyy V.V., Zavestovskaya I.N., Popov Y.M., Cheshev E.A., Fronya A.A.	📍 FIAN

THURSDAY

12:45 — 14:20	■	LAB		Latex Basics	🎓 Kuznetsov A.V.	📍 K-1102
14:30 — 16:05	☑	LEC		Management of Intellectual Property	🎓 Yushkov E.S.	📍 V-404
	☑	SEM		Management of Intellectual Property	🎓 Yushkov E.S.	📍 V-404

FRIDAY

09:20 — 11:50	■	SEM		Modern Laser Technologies	🎓 Fronya A.A.	📍 FIAN
11:55 — 13:30	■	PR		Practical Training (Research Work)	🎓 Popov Y.M., Marmalyuk A.A., Krohin O.N., Kanavin A.P., Zasavitskiy I.I., Bezotosnyy V.V., Zavestovskaya I.N., Cheshev E.A., Fronya A.A.	📍 FIAN